

PATENT  
2332-0117P#6/ Suppl  
Amend  
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## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KIM, Jeong Soo, et al. Conf. No.: 4564  
Appl. No.: 09/998,134 Group: 2823  
Filed: December 3, 2001 Examiner: Thanh V. PHAM  
For: METHOD OF FORMING A JUNCTION IN SEMICONDUCTOR  
DEVICE USING HALO IMPLANT PROCESSING (To Be  
Amended)

**SUPPLEMENTAL AMENDMENT**

Honorable Commissioner of Patents  
Washington, D.C. 20231

August 22, 2002

Sir:

In response to the Examiner's Office Action dated May 8, 2002, the following supplemental amendments and remarks are respectfully submitted in connection with the above-identified application.

**IN THE TITLE**

Please replace the present title with the following:

--METHOD OF FORMING A JUNCTION IN SEMICONDUCTOR DEVICE  
USING HALO IMPLANT PROCESSING--